Ref #	Hits	Search Query	DBs	Default Operator	Plurais	Time Stamp
<u> </u>	2	(nano\$1probe (nano adj probe)) with ((substrate material \$5film coat\$3 layer sheet pad wafer film lamina level plane) with silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	S.	NO	2005/03/23 14:36
2	2	l1 and @ad<"20030922"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	SO.	NO	2005/03/23 14:35
ៗ	45	(nano\$1probe (nano adj probe)) with (substrate material \$5film coat\$3 layer sheet pad wafer film lamina level plane)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	S.	NO	2005/03/23 15:23
4	35	l3 and @ad<"20030922"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	S S	NO	2005/03/23 15:23
15	23	14 and silicon	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR.	NO	2005/03/23 14:36
77	m	I5 and (project\$5 protrud\$5 extend\$5) near2 (portion part member moiety parcel piece section segment)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	S. S	N O	2005/03/23 14:37
116	76	(nano\$1probe (nano adj probe)) same (substrate material \$5film coat\$3 layer sheet pad wafer film lamina level plane)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	NO	2005/03/23 15:23

117	99	66 116 and @ad<"20030922"	ЭВ;	R	8 O	2005/03/23 15:23
			USPAT; EPO; JPO; DERWENT; TPM TES	·		
170	7	117 and ((project\$5 protrud\$5 extend\$5) near2 (portion part member moiety parcel piece section segment))		æ	N O	2005/03/23 15:29
			DERWENT; IBM_TDB			
121	m	I20 and (conduct\$5 near2 (wir\$3 cord\$3 cabl\$3 line link channel connect\$5 lead\$3))	US-PGPUB; USPAT; EPO; JPO;	Ř	NO	2005/03/23 15:27
			DERWENT; IBM_TDB			